

Acknowledgments

The authors thank the Karlsruhe Nano Micro Facility (KNMF), a Helmholtz Research Infrastructure for the possibility to fabricate the lenses with x-ray lithography. The work was performed within the Helmholtz Virtual Institute of New x-ray Analytic Methods in Material Science (VI-NXMM). We acknowledge support by Deutsche Forschungsgemeinschaft and Open Access Publishing Fund of Karlsruhe Institute of Technology.